

Notice of References Cited	Application/Control No. 10/747,946	Applicant(s)/Patent Under Reexamination SHIM ET AL.	
	Examiner Thanh T. Nguyen	Art Unit 2813	Page 1 of 1

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
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	C	US-6,482,726	11-2002	Aminpur et al.	438/585
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NON-PATENT DOCUMENTS

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	U	Wolf, Stanley "silicon proceessing for the VLSI ERA" 1986, Vol. 2, pages 542-551.
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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.